

09/856384

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
UNITED STATES DESIGNATED/ELECTED OFFICE**

Applicant: Kiyoshi MOTEGI &  
Satoru OSHIKAWA

GAU:

International Application  
PCT/JP99/03985

Examiner:

Int'l Filing Date: 26 July 1999

Atty. Docket No.  
25,096-USA

For: OPTICAL APPARATUS, EXPOSURE  
APPARATUS, LASER LIGHT SOURCE,  
GAS SUPPLY METHOD, EXPOSURE  
METHOD, AND DEVICE MANUFACTURING  
METHOD

Box PCT  
Attn: DO/EO/US  
Commissioner for Patents  
Washington, D.C. 20231

**PRELIMINARY AMENDMENT**

Sir:

Please amend the application as set forth below. The calculation of the filing fees should be based on the claims as amended herein.

**In The Specification**

On page 1, line 5, delete the heading "Technical Field" and replace it with the following:

- -BACKGROUND OF THE INVENTION- -

On page 1, line 17, delete the heading "Background Art."

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